

Analysis Update: MC study for pp  
collisions at  $\sqrt{s} = 13 \text{ TeV}$

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## Motivation

To propose a possible measurement to study new effects in events with a high number of MPI that could be measured with a device that has a wide coverage in pseudorapidity  
 $|\eta| < 4$ .

## Features

$$|\eta| < 4$$

Near Side (NS):

$$|\phi| < \frac{\pi}{3}$$

Away Side (AS):

$$|\phi| > \frac{2\pi}{3}$$

Transverse Side (TS):

$$\frac{\pi}{3} < |\phi| < \frac{2\pi}{3}$$

$P_T^{\text{leading}}$ : The largest  $P_T$  produced by a jet at the event.

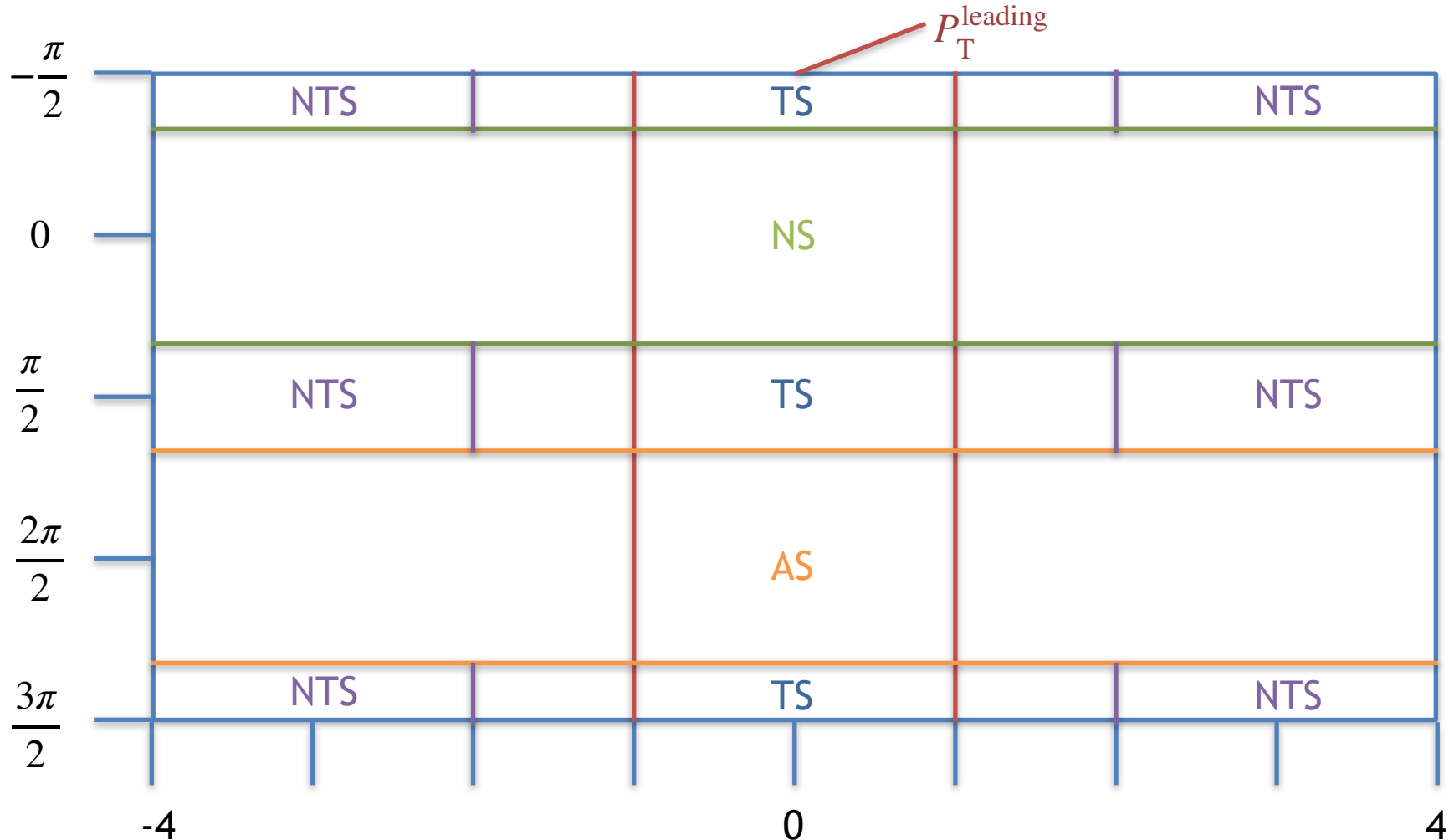
$$0.15 \frac{\text{GeV}}{c} < P_T^{\text{leading}} < 50 \frac{\text{GeV}}{c}$$

$$|\eta| < 0.8$$

$P_T^{\text{associated}}$ :  $P_T$  associated with the other hadrons in the jet.

$$0.15 < \frac{\text{GeV}}{c} < P_T^{\text{associated}}$$

# New Topological region



$|\eta| < 4$

$-\frac{\pi}{2} < \Delta\phi < \frac{3\pi}{2}$

NTS

$|\Delta\eta| < 3.2$   
and  
 $|\Delta\eta| > 2$

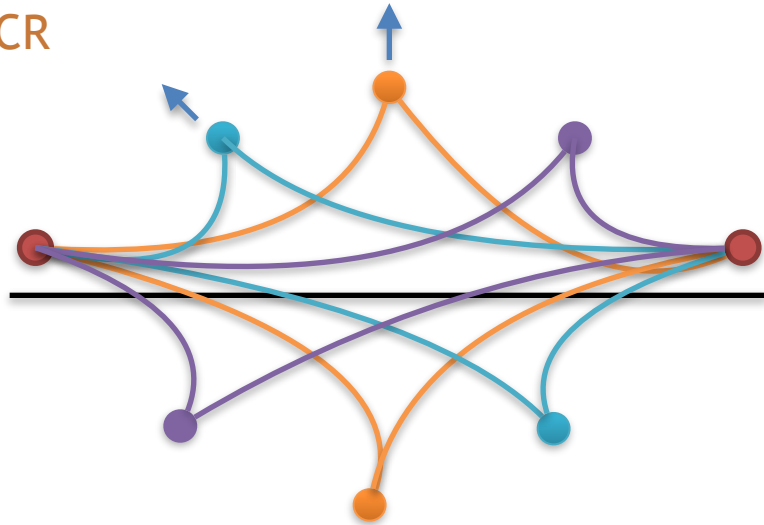
# Colour Reconnection (CR)

The MPI-based original Pythia 8 scheme.

Mechanism that allows the partons to interact before hadronizing.

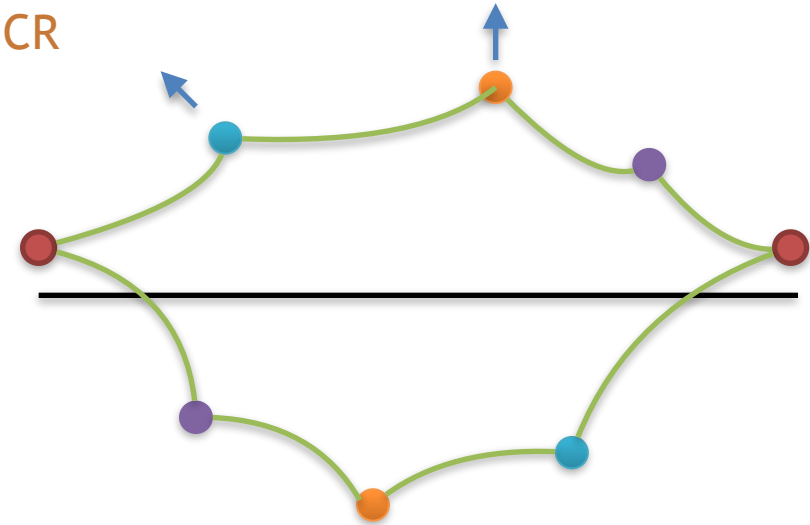
- Beam remnants
- ● ● Gluons and quarks

Without CR



$$N_{ch} \sim 12 \langle N_{ch}^S \rangle$$

With CR



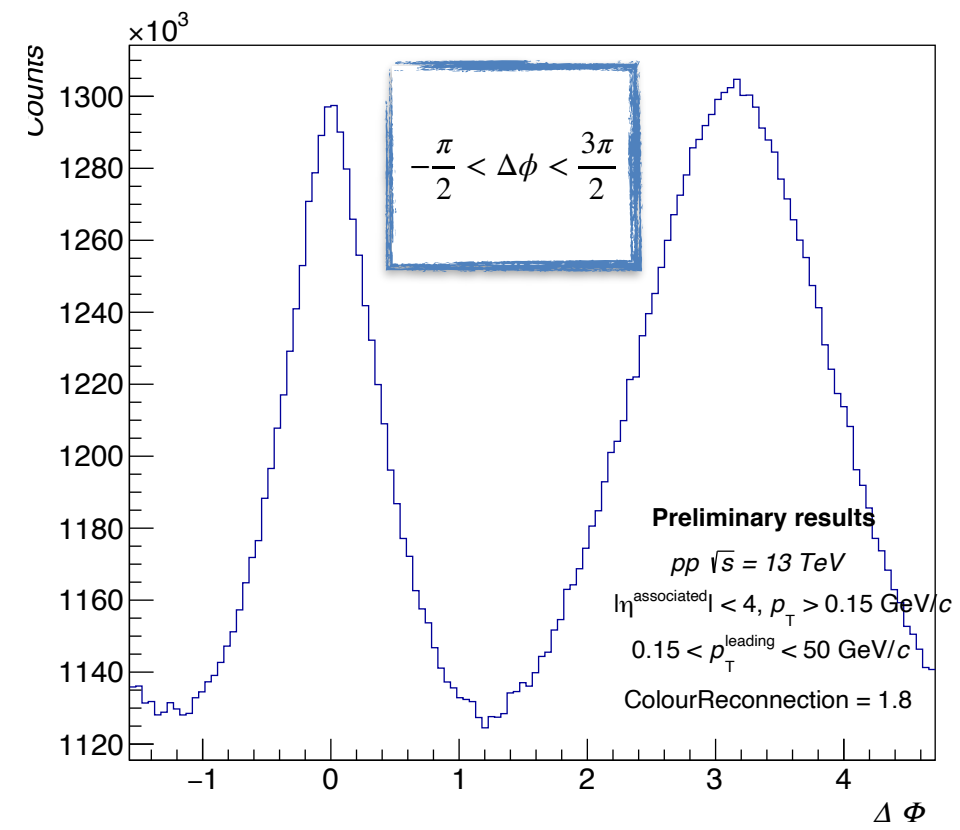
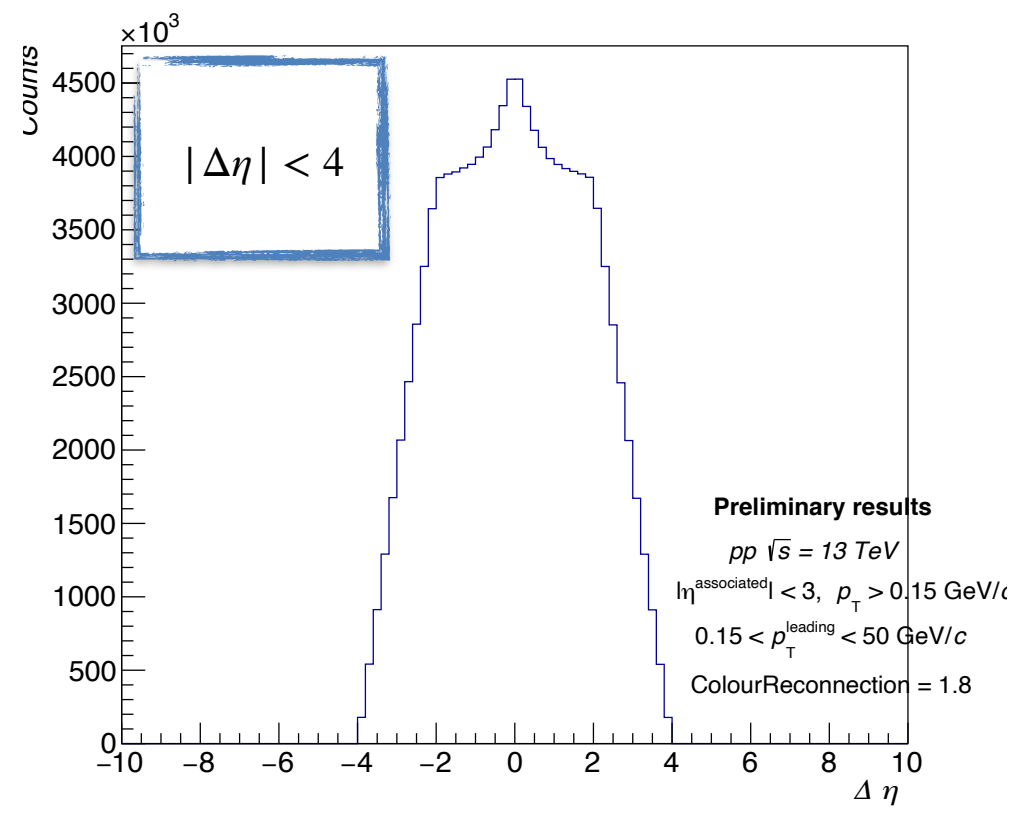
$$N_{ch} \sim 8 \langle N_{ch}^S \rangle$$

# Hadronic correlations

For each pair of particles, the hadronic correlations can be defined as follows

$$\Delta\eta = \eta^a - \eta^l$$

$$\Delta\phi = \phi^a - \phi^l$$



# In the previous presentation



Study how  $\langle p_T \rangle$  changes considering different windows of total multiplicity.

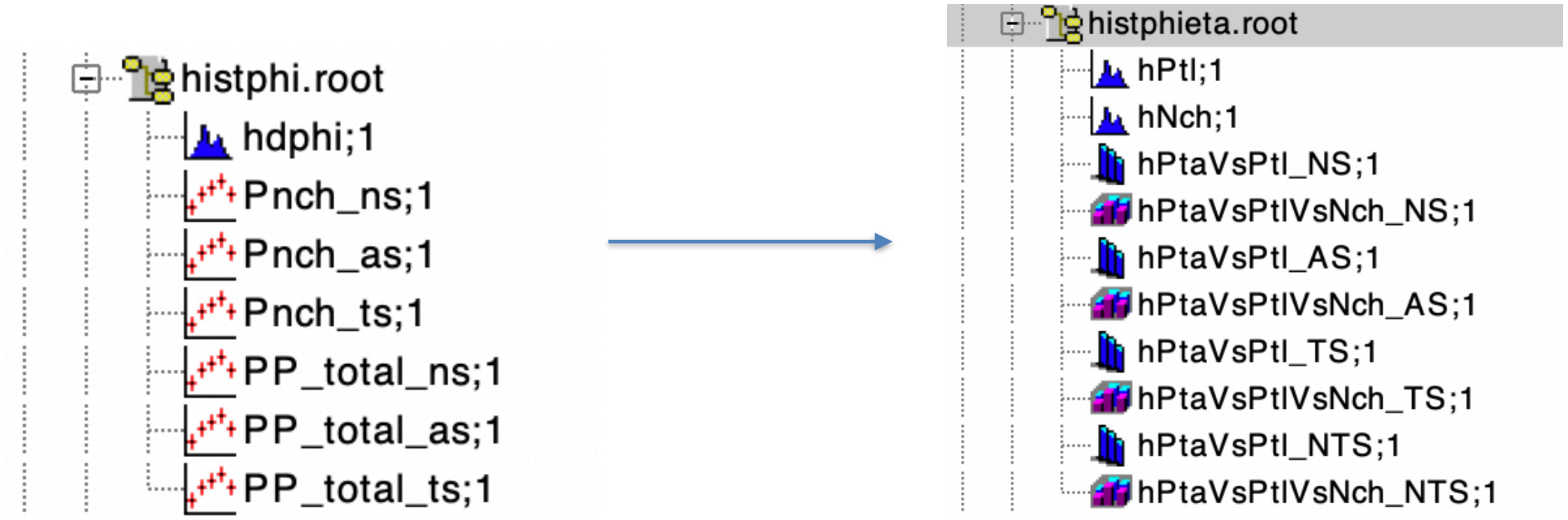


Add the parameter  $\frac{\rho}{\langle \rho \rangle}$  to distinguish between high and low MPI.



Include other event generators in the analysis

# So far



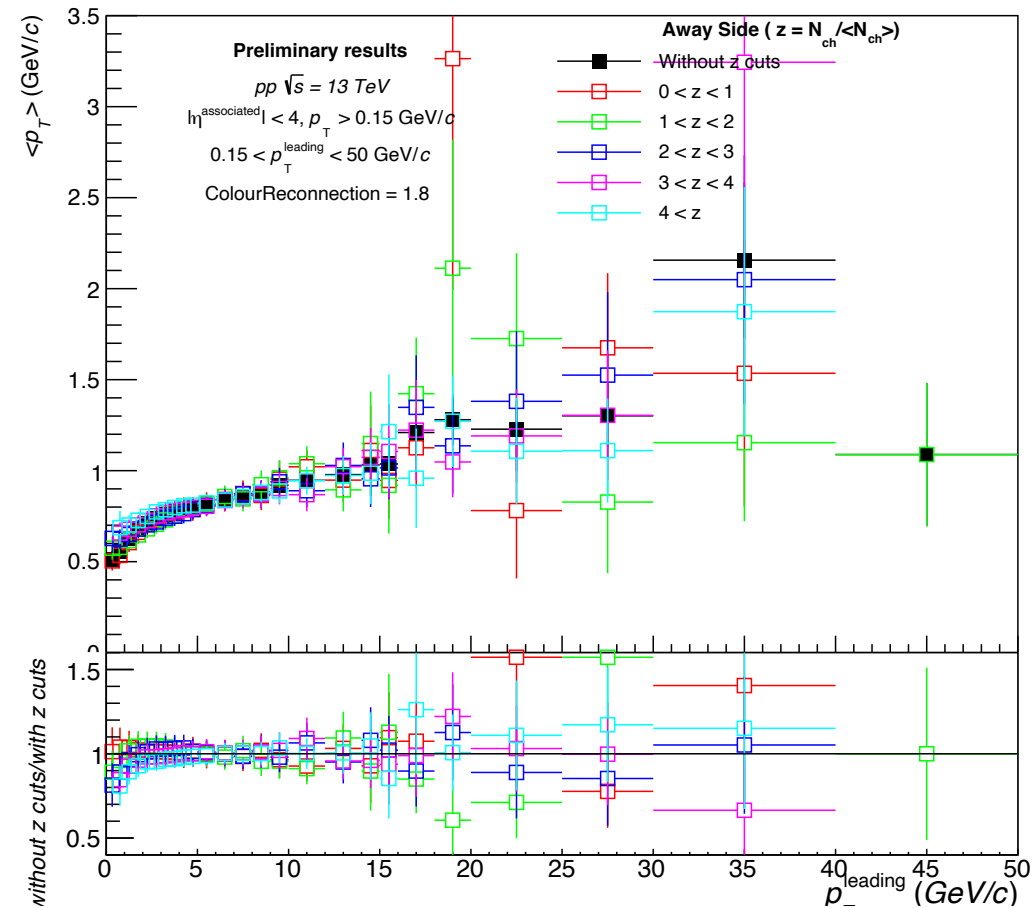
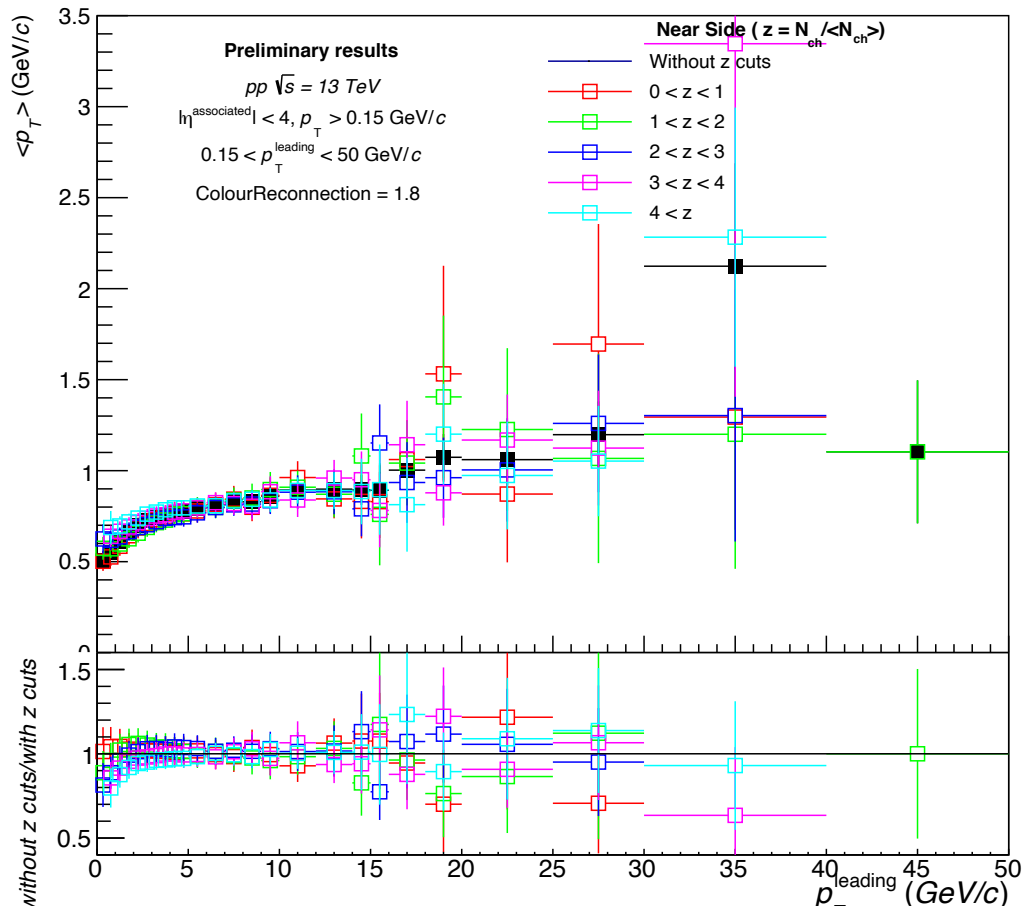


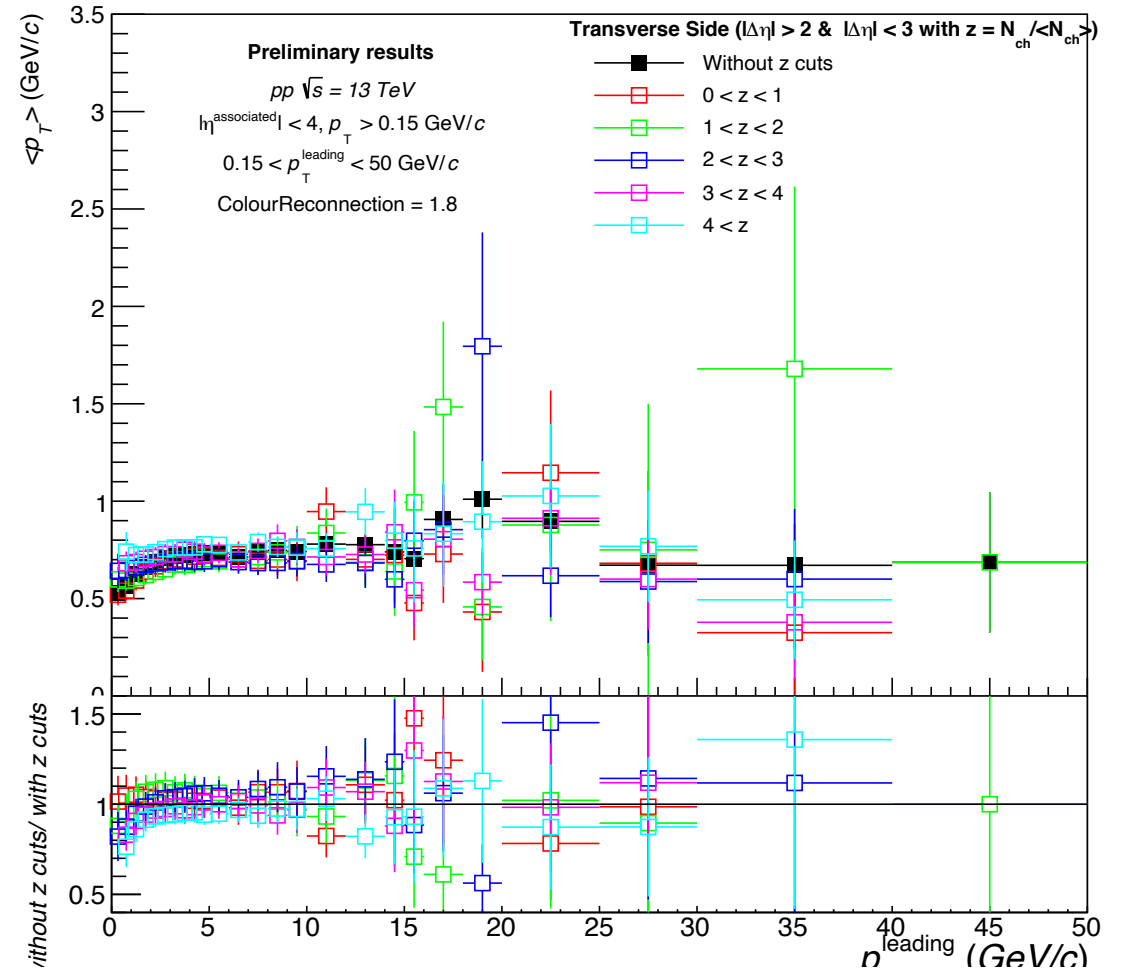
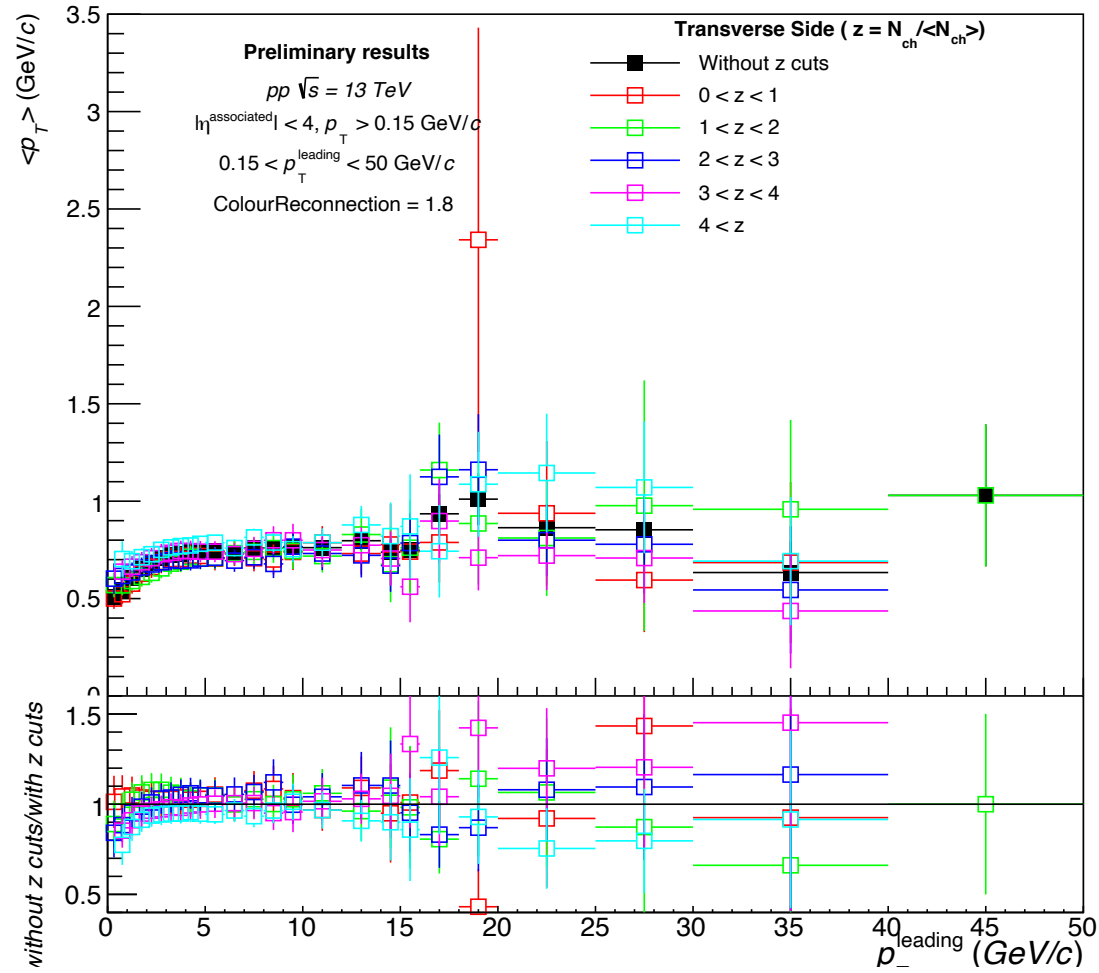
# $\langle p_T \rangle$ distribution

New Variable:  

$$z = \frac{N_{ch}}{\langle N_{ch} \rangle}$$

Spectra is studied to observe a possible effect of additional contamination coming from the hard process.





Thank you

